

220158US-2X DIV

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF: :

MASATAKA HASEGAWA ET AL : ATTN: APPLICATION DIVISION

SERIAL NO: NEW U.S. APPLICATION :

FILED: HEREWITH :

FOR: DIAMOND SEMICONDUCTOR AND
METHOD FOR THE FABRICATION
THEREOF

PRELIMINARY AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Prior to a first examination on the merits, please amend the above-identified application as follows:

IN THE CLAIMS

Please cancel claims 1 and 2 without prejudice.

REMARKS

Favorable consideration of this application, as presently amended, is respectfully requested.

The present application is a divisional of copending parent U.S. application serial no. 09/621,360. In that parent application Claims 3-6 were withdrawn as directed to a non-

elected invention. The present new Divisional application is submitted to further prosecute those claims 3-6 withdrawn in the parent of the present application. Thus, by the present preliminary amendment claims 1 and 2 are canceled so that claims 3-6 are pending.

The present application is believed to be in condition for a full and thorough examination on the merits. An early and favorable consideration of the present application is hereby respectfully requested.

Respectfully submitted,

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Serial No: New Div
Amendment Filed on:
Herewith

IN THE CLAIMS

--Claims 1 and 2 (Canceled).--